

IFW 2891

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Sujit Sharan et al.

Title: METHOD FOR PECVD DEPOSITION OF SELECTED MATERIAL FILMS

Docket No.: 303.930US4

Filed: April 3, 2001

Examiner: Asok K Sarkar

Serial No.: 09/825,613

Due Date: October 3, 2006

Group Art Unit: 2891

**MS Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450



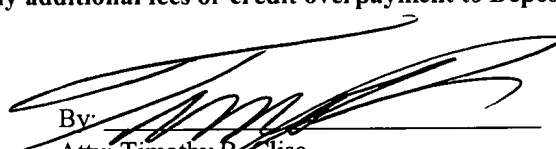
We are transmitting herewith the following attached items (as indicated with an "X"):

- ☒ Return postcard.
- ☒ Amendment and Response (8 pgs.).
- ☒ Communication Concerning Related Applications (1 pg.).

If not provided for in a separate paper filed herewith, Please consider this a **PETITION FOR EXTENSION OF TIME** for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

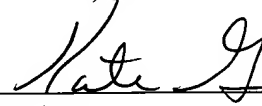
SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number 21186

By:   
Atty: Timothy B. Clise  
Reg. No. 40,957

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 3 day of October, 2006.

  
Name

  
Signature

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

(GENERAL)

S/N 09/825,613

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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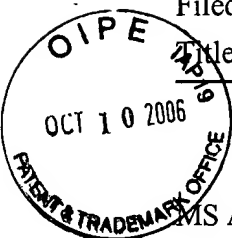
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COMMUNICATION CONCERNING RELATED APPLICATION(S)

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Applicants would like to bring to the Examiner's attention the following related application(s) in the above-identified patent application:

<u>Serial/Patent No.</u>	<u>Filing Date/Issue Date</u>	<u>Attorney Docket</u>	<u>Title</u>
09249478 6291341	February 12, 1999	303.930US1	METHOD FOR PECVD DEPOSITION OF SELECTED MATERIAL FILMS
09825612	April 3, 2001	303.930US2	METHOD FOR PECVD DEPOSITION OF SELECTED MATERIAL FILMS
09825611 7093559	April 3, 2001	303.930US3	METHOD FOR PECVD DEPOSITION OF SELECTED MATERIAL FILMS
11382444	May 9, 2006	303.930US5	METHOD FOR PECVD DEPOSITION OF SELECTED MATERIAL FILMS

Continuations and divisionals may be later filed on the cases listed above, or cited to the Examiner in any previous Communication Concerning Related Applications. Applicants request that the Examiner review all continuations and divisionals of the above-listed or previously-cited patent applications before allowing the claims of the present patent application.

Respectfully submitted,  
SUJIT SHARAN ET AL.  
By Applicants' Representatives,  
SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.  
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3 Oct '06

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Name

KATE GANNON

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